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ABSTRACT OF THE DISCLOSURE

2 A method of relocating spacers using inductive
3 attraction. A chuck employs the inductive attraction to
4 lift field emission display (FED) spacers, wherein the
5 spacers are provided with susceptibility to the employed
6 attraction. The spacers are lifted by the chuck and
7 relocated to a desired position. The inductive process
8 uses a non-contact force, including electrostatic and
9 magnetic forces.